

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. HIROI, et al
Serial No.: 10/062,666
Filed: February 5, 2002
For: PATTERN INSPECTION METHOD AND
SYSTEM THEREFOR
Group: 2881
Examiner: J. Berman
Conf. No.: 4688

AMENDMENT AFTER FINAL REJECTION

Mail Stop: Amendment (Fee)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 30, 2009

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated April 30, 2009, and in light of the telephone discussion with the Examiner of September 24, 2009. The amendments submitted are as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.